



Attorney Docket No.: YOR920030410US1

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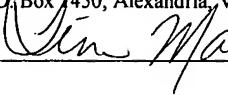
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Applicant(s): Daniel C. Worledge  
Docket No.: YOR920030410US1  
Serial No.: 10/699,284  
Filed: October 31, 2003  
Group: 2818  
Examiner: Unassigned

Title: Techniques for Coupling in Semiconductor Devices

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Signature:  Date: March 7, 2005

STATUS REQUEST

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

To date, we have received no communication or official action from the Examiner in charge of the above-identified patent application. Please let us know the status of this case.

Respectfully submitted,



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